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EE C245 - ME C218 Introduction to MEMS Design Fall 2010

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Lecture Module 2: Benefits of Scaling

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Basic Concept: Scaling Guitar Strings

Guitar String

Vib. Amplitude vs Freq. (110 Hz)

Vibrating "A" String (110 Hz)

Freq. Equation:

$$f_o = \frac{1}{2\pi} \sqrt{\frac{k_r}{m_r}}$$

Stiffness (k_r) and Mass (m_r) are indicated in the equation.

μMechanical Resonator

[Bannon 1996]

Performance:
L_r=40.8μm
m_r ~ 10⁻¹³ kg
W_r=8μm, h_r=2μm
d=1000Å, V_p=5V
Press.=70mTorr

f_o=8.5MHz
Q_{vac}=8,000
Q_{air}~50

Transmission [dB] vs Frequency [MHz]

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3CC 3λ/4 Bridged μMechanical Filter

Performance:
f_o=9MHz, BW=20kHz, PBW=0.2%
I.L.=2.79dB, Stop. Rej.=51dB
20dB S.F.=1.95, 40dB S.F.=6.45

Transmission [dB] vs Frequency [MHz]

[S.-S. Li, Nguyen, FCS'05]

Design:
L=40μm
W_r=6.5μm
h_r=2μm
L_c=3.5μm
L_p=1.6μm
V_p=10.47V
P=5dBm
R_{Qr}=R_{Qo}=12kΩ

[Li, et al., UFFCS'04] LecM 2 C. Nguyen 8/20/09 3

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1.51-GHz, Q=11,555 Nanocrystalline Diamond Disk μMechanical Resonator

- Impedance-mismatched stem for reduced anchor dissipation
- Operated in the 2nd radial-contour mode
- Q ~11,555 (vacuum); Q ~10,100 (air)
- **Below:** 20 μm diameter disk

Design/Performance:
R=10μm, t=2.2μm, d=800Å, V_p=7V
f_o=1.51 GHz (2nd mode), Q=11,555

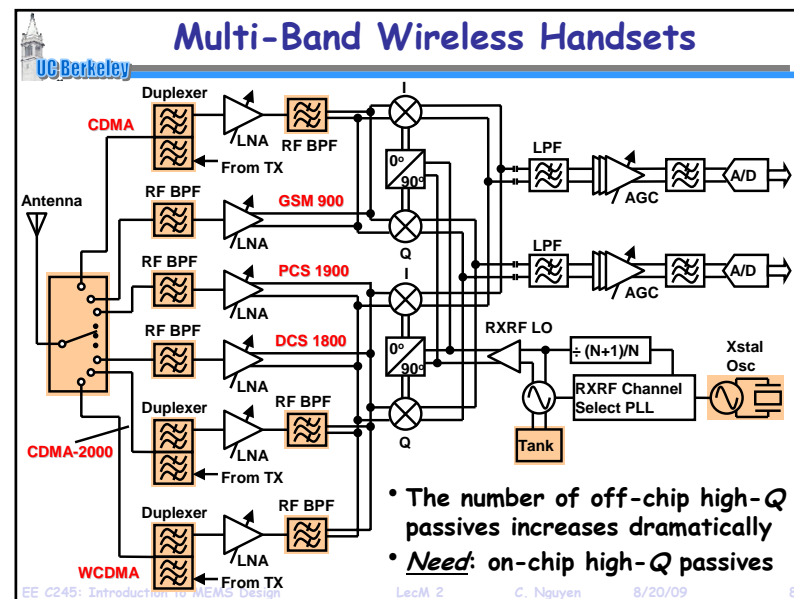
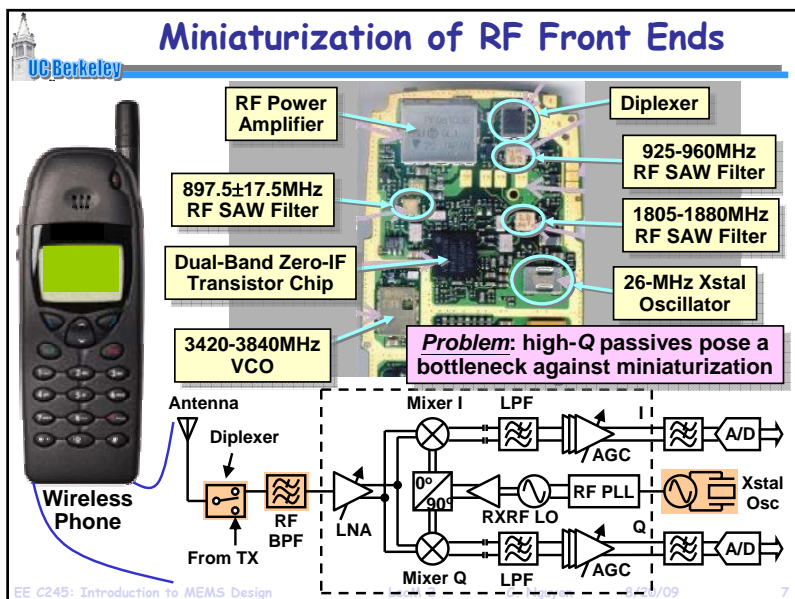
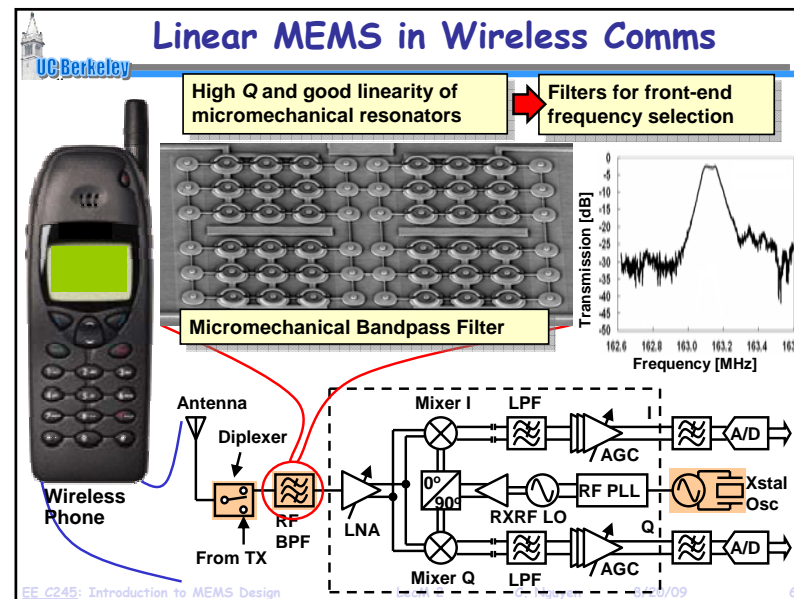
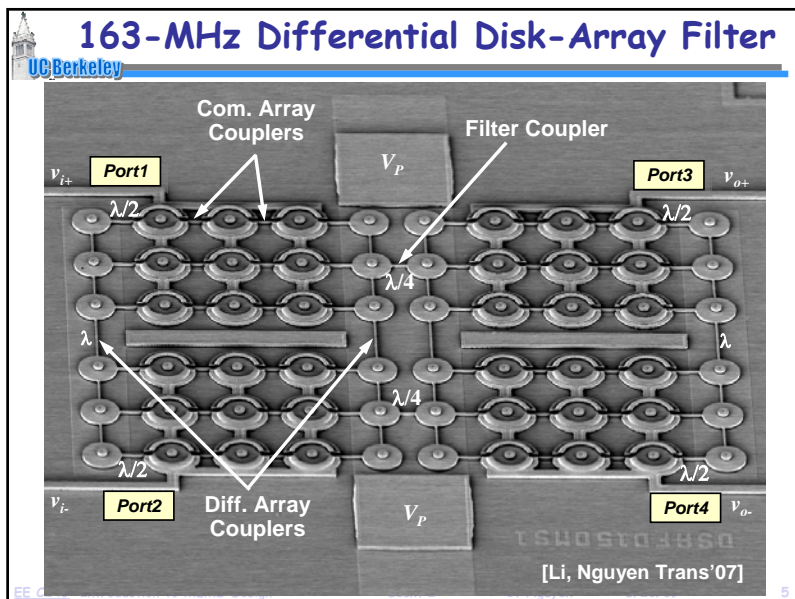
Mixed Amplitude [dB] vs Frequency [MHz]

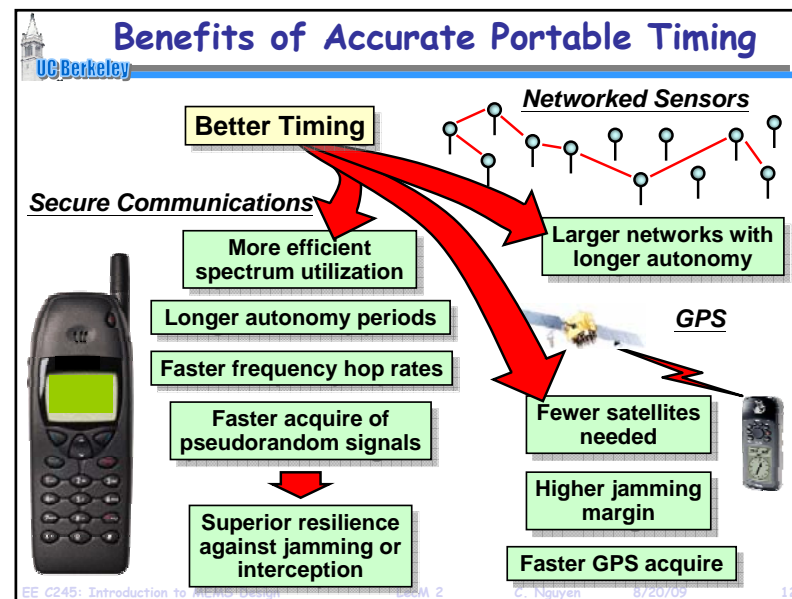
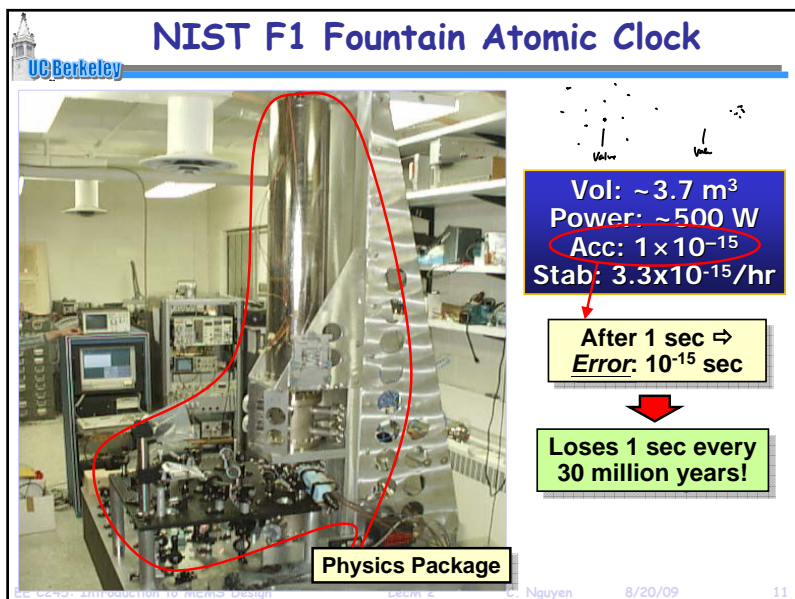
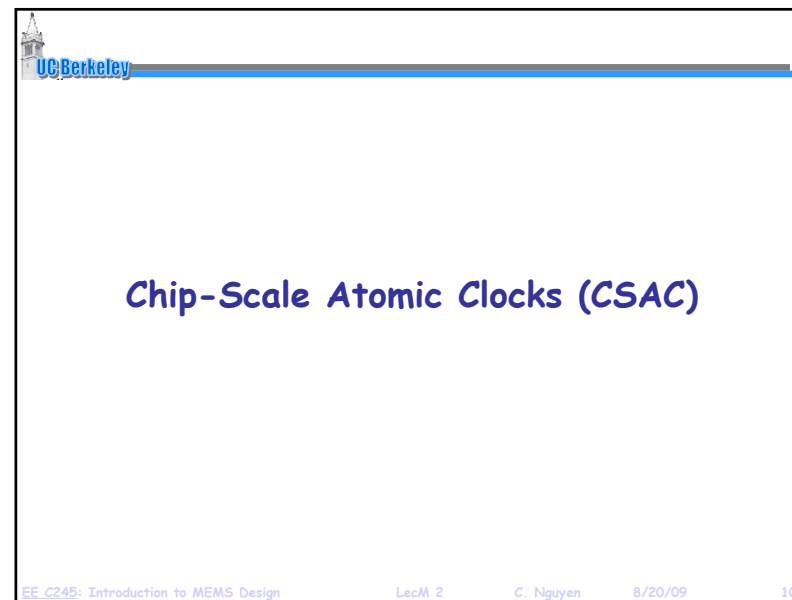
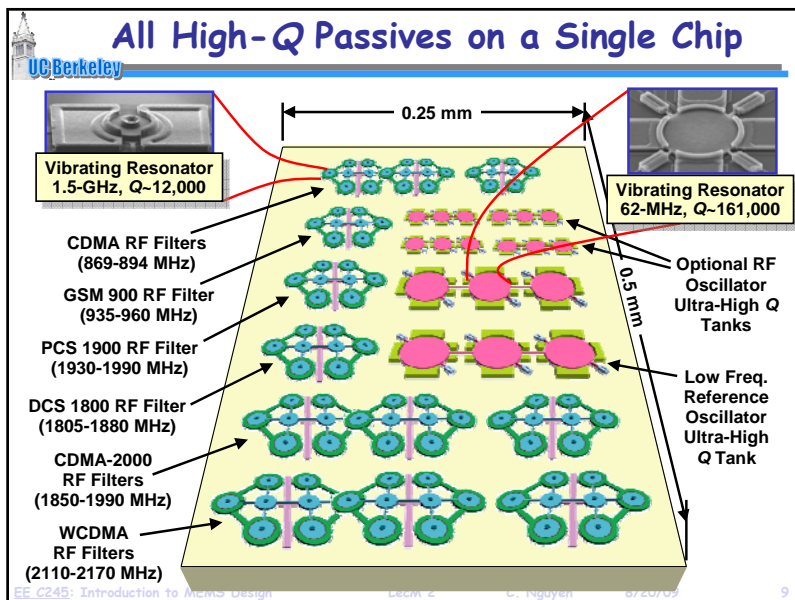
f_o = 1.51 GHz
Q = 11,555 (vac)
Q = 10,100 (air)

Q = 10,100 (air)

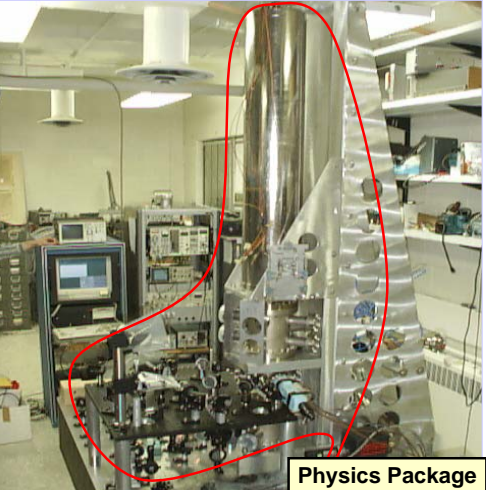
[Wang, Butler, Nguyen MEMS'04]

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NIST F1 Fountain Atomic Clock



Vol: ~3.7 m³
Power: ~500 W
Acc: 1 × 10⁻¹⁵
Stab: 3.3 × 10⁻¹⁵/hr

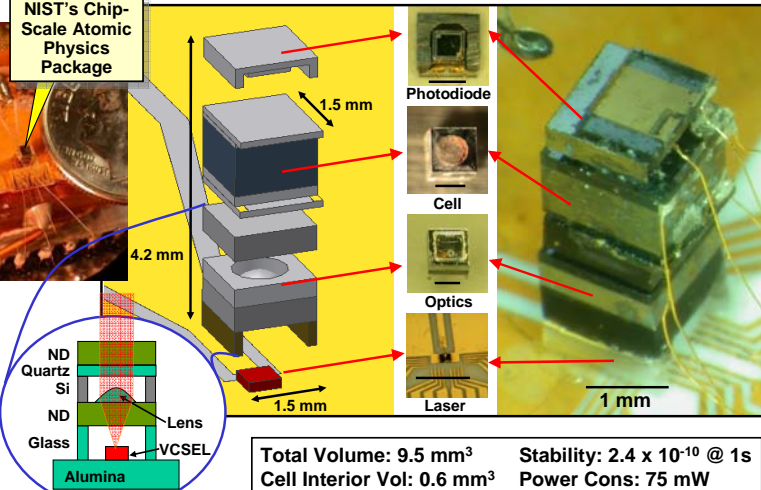
After 1 sec ⇨
Error: 10⁻¹⁵ sec

↓

Loses 1 sec every 30 million years!

Physics Package

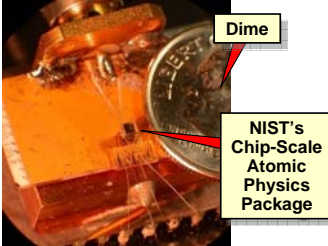
1st Chip-Scale Atomic Physics Package



Total Volume: 9.5 mm³ **Stability: 2.4 × 10⁻¹⁰ @ 1s**
Cell Interior Vol: 0.6 mm³ **Power Cons: 75 mW**

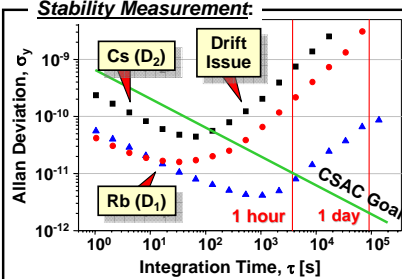
Labels: ND, Quartz, Si, ND, Glass, Alumina, VCSEL, Lens, Laser, Optics, Cell, Photodiode.

Tiny Physics Package Performance

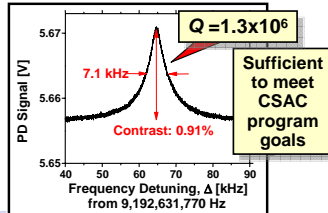


Experimental Conditions:
 Cs D2 Excitation
 External (large) Magnetic Shielding
 External Electronics & LO
 Cell Temperature: ~80 °C
 Cell Heater Power: 69 mW
 Laser Current/Voltage: 2mA / 2V
 RF Laser Mod Power: 70μW

Stability Measurement:



Open Loop Resonance:

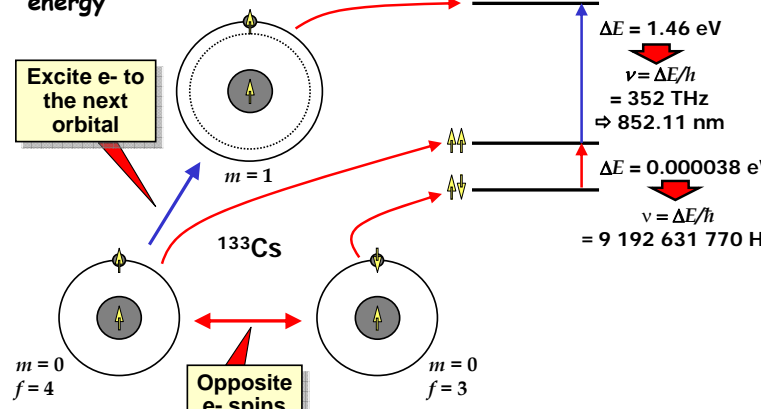


Q = 1.3 × 10⁶
7.1 kHz
Contrast: 0.91%
 Sufficient to meet CSAC program goals

Atomic Clock Fundamentals

Frequency determined by an atomic transition energy

Energy Band Diagram



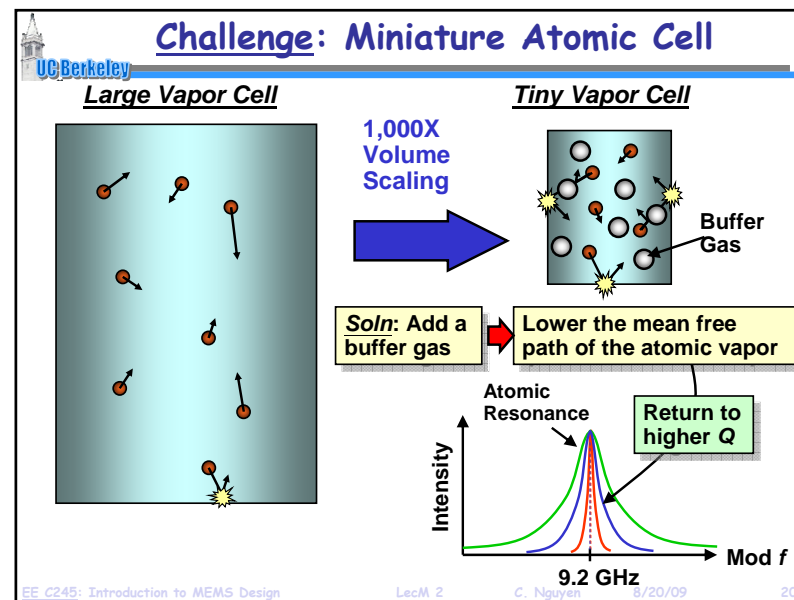
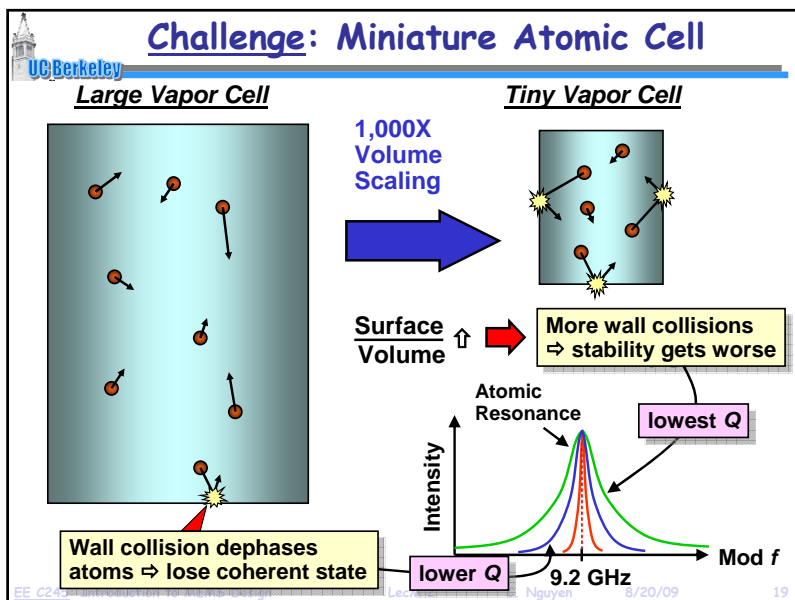
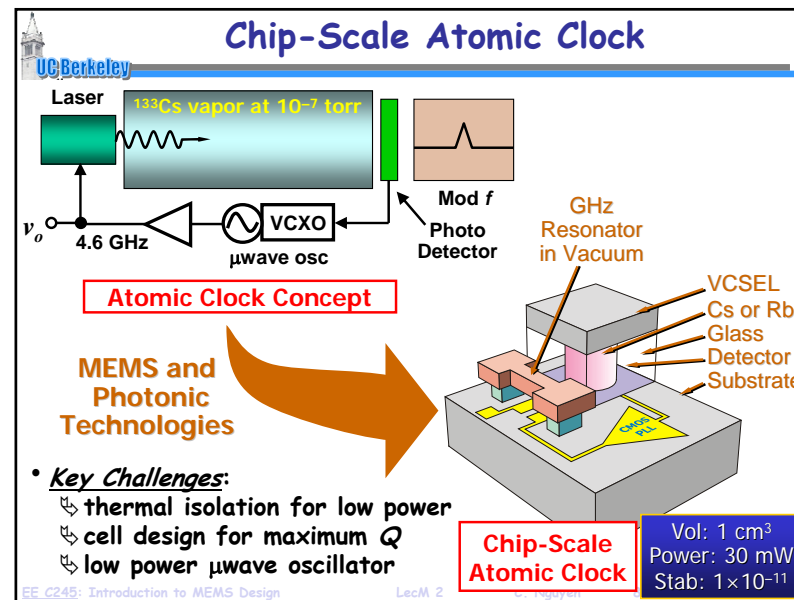
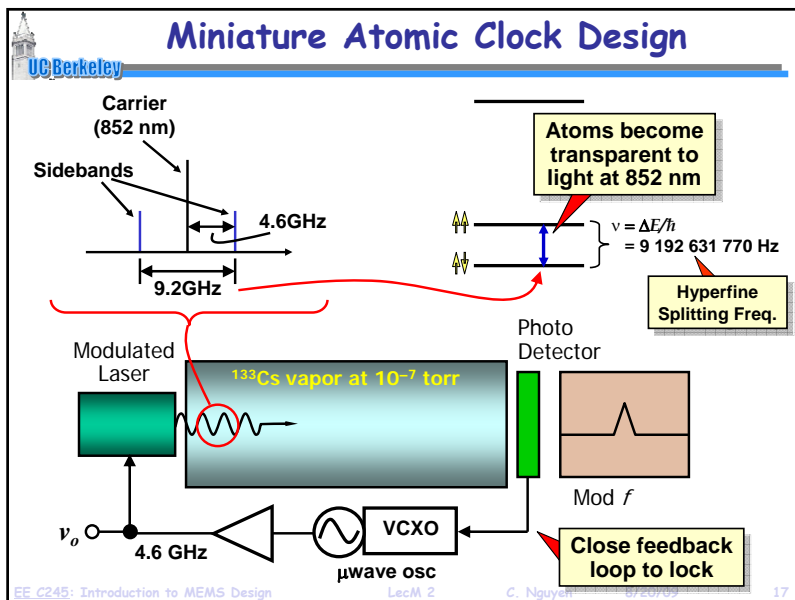
Excite e- to the next orbital

Opposite e- spins

133Cs

$\Delta E = 1.46 \text{ eV}$
 $\nu = \Delta E/h = 352 \text{ THz}$
 $\Rightarrow 852.11 \text{ nm}$

$\Delta E = 0.000038 \text{ eV}$
 $\nu = \Delta E/h = 9\,192\,631\,770 \text{ Hz}$



UC Berkeley Chip-Scale Atomic Clock

Atomic Clock Concept

MEMS and Photonic Technologies

- **Key Challenges:**
 - thermal isolation for low power
 - cell design for maximum Q
 - low power μ wave oscillator

Chip-Scale Atomic Clock

Vol: 1 cm^3
Power: 30 mW
Stab: 1×10^{-11}

UC Berkeley Micro-Scale Oven-Control Advantages

Macro-Scale

Macro-Oven (containing heater and T sensor)

Atomic Cell @ 80°C

Thermally Isolating Feet

$R_{th} = 70 \text{ K/W}$
 $C_{th} = 26 \text{ J/K}$

$P (@ 80^\circ\text{C}) = 0.8 \text{ W}$
Warm Up, $\tau = 30 \text{ min.}$

Micro-Scale

$300 \times 300 \times 300 \mu\text{m}^3$ Atomic Cell @ 80°C

Heater
Laser

Long, Thin Polysilicon Tethers

T Sensor (underneath)

$R_{th} = 83,000 \text{ K/W}$
 $C_{th} = 6.3 \times 10^{-6} \text{ J/K}$

$P (@ 80^\circ\text{C}) = 2.6 \text{ mW}$
Warm Up, $\tau = 0.1 \text{ s}$

$T = P \times R_{th}$

$R_{th} \sim \frac{\text{support length}}{\text{X-section area}}$
 $C_{th} \sim \text{volume}$

308x lower power
18,000x faster warm up

UC Berkeley Physics Package Power Diss. < 10 mW

• Achieved via MEMS-based thermal isolation

Cesium cell

Heater/Sensor Suspension

VCSEL / Photodiode

Frame Spacer

VCSEL Suspension

Symmetricom / Draper Physics Package Assembly

20 pin LCC

7 mm

Only ~5 mW heating power needed to achieve 80°C cell temperature

Power [mW]

Temperature [$^\circ\text{C}$]

Measured (blue diamonds)
Model (red line)